

FORM PTO-1449 LIST OF PATENTS AND OTHER ITEMS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 0150141	SERIAL NO. 101692431 Not Assigned
	APPLICANTS: Dornisch, et al.	
	FILING DATE: Herewith	GROUP ART: Not Assigned

U.S. PATENT DOCUMENTS							
Exam. Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	AA						
	AB						
	AC						

FOREIGN PATENT DOCUMENT								
Exam. Initials		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION	
							YES	NO
	BA							
	BB							
	BC							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
EO	CA	Won, et al., "Novel Plasma Enhanced Atomic Layer Deposition Technology for High-k Capacitor with EOT of 8Å on Conventional Metal Electrode"; 2003 Symposium on VLSI Technology Digest of Technical Papers, 4-89114-035-6/03.
	CB	

EXAMINER: <i>[Signature]</i>	DATE CONSIDERED: 7/20/04
EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.	
Information Disclosure Statement -- Section 9 PTO-1449	
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